

Alain E Kaloyeros

List of Publications by Year in descending order

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6
papers

228
citations

2257833

3
h-index

2053595

5
g-index

6
all docs

6
docs citations

6
times ranked

341
citing authors

#	ARTICLE	IF	CITATIONS
1	Reviewâ€™Silicon Nitride and Silicon Nitride-Rich Thin Film Technologies: Trends in Deposition Techniques and Related Applications. ECS Journal of Solid State Science and Technology, 2017, 6, P691-P714.	0.9	114
2	Reviewâ€™Silicon Nitride and Silicon Nitride-Rich Thin Film Technologies: State-of-the-Art Processing Technologies, Properties, and Applications. ECS Journal of Solid State Science and Technology, 2020, 9, 063006.	0.9	64
3	Editors' Choiceâ€™Reviewâ€™Cobalt Thin Films: Trends in Processing Technologies and Emerging Applications. ECS Journal of Solid State Science and Technology, 2019, 8, P119-P152.	0.9	45
4	Emerging Molecular and Atomic Level Techniques for Nanoscale Applications. Electrochemical Society Interface, 2018, 27, 59-63.	0.3	3
5	The low-temperature remote-plasma-activated pulsed chemical vapor deposition route to SiNx from 1,3,5-tri(isopropyl)cyclotrisilazane. Thin Solid Films, 2020, 711, 138299.	0.8	2
6	Simplified CVD route to near-zero thickness silicon nitride films. Journal of Vacuum Science and Technology B:Nanotechnology and Microelectronics, 2022, 40, 040601.	0.6	0